

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05918-083002	Application No. 09/745,786
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Thomas G. Lacey, et al.	
		Filing Date December 21, 2000	Group Art Unit 3626

U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	5A	5,385,706	Jan. 31, 1995	Thomas, Dennis A.			
	5B						
	5C						
	5D						
	5E						
	5F						
	5G						
	5H						
	5I						
	5J						
	5K						

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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

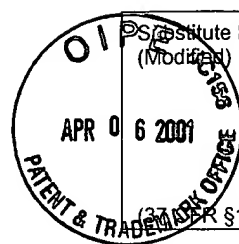
Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

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Examiner Signature <i>M. E. Lacey</i>	Date Considered 20/Jun/83
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 Applicant
 Thomas G. Lacey, et al.

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U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
MC	AA	3,312,583	04/04/1967	Rochlis	161	62	
MC	AB	3,507,010	04/21/1970	Doleman et al.	18	21	
MC	AC	3,557,407	01/26/1971	Lemelson	18	10	
MC	AD	3,590,109	06/29/1971	Doleman et al.	264	167	
MC	AE	3,752,619	08/14/1973	Menzin et al.	425	134	
MC	AF	3,758,657	09/11/1973	Menzin et al.	264	166	
MC	AG	3,762,000	10/02/1973	Menzin et al.	24	204	
MC	AH	4,162,757	07/31/1979	Lemelson	228	1 R	
MC	AI	4,725,221	02/16/1988	Blanz	425	575	
MC	AJ	4,794,028	12/27/1983	Fischer	428	100	
MC	AK	4,984,339	01/15/1991	Provost et al.	24	452	
MC	AL	5,058,247	10/22/1991	Thomas et al.	24	448	
MC	AM	5,077,870	01/07/1992	Melbye et al.	24	452	
MC	AN	5,116,563	05/26/1992	Thomas et al.	264	167	
MC	AO	5,131,119	07/21/1992	Murasaki et al.	24	452	
MC	AP	5,162,074	11/10/1992	Hills	156	644	
MC	AQ	5,176,670	01/05/1993	Roessler et al.	604	391	
MC	AR	5,235,731	08/17/1993	Anzai et al.	24	576	
MC	AS	5,242,646	09/07/1993	Torigoe et al.	264	219	
MC	AT	5,312,456	05/17/1994	Reed et al.	411	456	
MC	AU	5,315,740	05/31/1994	Provost	24	452	
MC	AV	5,326,612	07/05/1994	Goulait	428	100	
MC	AW	5,339,499	08/23/1994	Kennedy et al.	24	452	
MC	AX	5,348,616	09/20/1994	Hartman et al.	156	643	
MC	AY	5,441,687	08/15/1995	Murasaki et al.	264	167	
MC	AZ	5,505,747	04/09/1996	Chelsey et al.	51	297	
MC	AAA	5,538,674	07/23/1996	Nisper et al.	264	1.31	

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U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
MC	ABB	5,604,963	02/25/1997	Akeno	24	452	
MC	ACC	5,679,302	10/21/1997	Miller et al.	264	167	
MC	ADD	5,692,271	12/02/1997	Provost et al.	24	452	
MC	AEE	5,781,969	07/21/1998	Akeno et al.	24	452	10/31/1996
MC	AFF	5,900,350	05/04/1999	Provost et al.	430	325	06/06/1996
MC	AGG	5,945,131	08/31/1999	Harvey et al.	425	141	04/16/1997
MC	AHH	5,971,738	10/26/1999	Jens et al.	425	194	01/21/1997
MC	AII	6,039,556	03/21/2000	Jens et al.	425	363	09/10/1997
	AJJ						

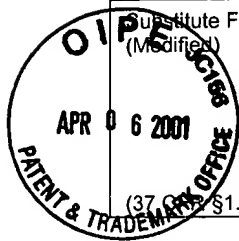
Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
MC	AKK	EP 0 464 754 A1 ✓	07/01/1991	EPO				
MC	ALL	EP 0 698 351 A2 ✓	08/24/1995	EPO				
MC	AMM	EP 0 714 614 A1 ✓	11/27/1995	EPO				
MC	ANN	GB 2 296 423 ✓	03/26/1997	UK				
MC	AOO	WO 94/23610 ✓	10/27/1994	WIPO				
MC	APP	WO 96/19960 ✓	07/04/1996	WIPO				
MC	AQQ	WO 97/46130 ✓	12/11/1997	WIPO				
MC	ARR	WO 98/20767 ✓	05/22/1998	WIPO				

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
MC	ASS ✓	"What is the Photo Chemical Machining Process and What Can It Do For You?", <i>Photo Chemical Machining Institute</i> -San Clemente, CA
MC	ATT ✓	Bennett, R.J., "Photo-Chemical Machining Fundamentals-With Three Unique Applications", <i>Technical Paper</i> , Creative Manufacturing Engineering Programs, Society of Manufact. Engineers, Dearborn, Michigan, 1976

Examiner Signature <i>M. E. Lacey</i>	Date Considered 201 Jan 03
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(37 CFR § 1.98(b))

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Other Documents (include Author, Title, Date, and Place of Publication)

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MO	AUU ✓	Freeman, H. "Manufacturing Metal Parts by the Photo-Chemical Machining Process", Conference Proceedings, Nontraditional Machining, Cincinnati, Ohio, 2-3 Dec. 1985, Carl Wegner, Chairman
MC	AVV ✓	Han et al, Micromechanical Velcro, J. of Micromechanical Systems, vol. 1 pp. 37-43, 1992
	AWW	

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